

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	)	
	)	
Goro NAKATANI et al.	)	Confirmation No.: 4701
	)	
Application No.: 10/043,276	)	Group Art Unit: 2811
	)	
Filed: January 14, 2002	)	Examiner: Junghwa M. Im
	)	
For: SEMICONDUCTOR DEVICE AND	)	<b>Mail Stop Amendment</b>
METHOD FOR MANUFACTURING	)	
THE SAME	)	

**Mail Stop Amendment**  
Commissioner of Patents  
U.S. Patent and Trademark Office  
Alexandria, VA 22314

Sir:

**AMENDMENT**

In response to the Office Action dated December 24, 2009, the period for response to which extends through March 24, 2010, please amend the above-identified application as follows: